

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	09/774,667	MIIDA, TAKASHI
	Examiner	Art Unit
	Gevell Selby	2615

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
348	294	6/3/05	GS
	298		
	300		
301			
308			